



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of)

Shunpei YAMAZAKI) Examiner: S. Loke

Serial No. 09/433,705) Art Unit: 2811

Filed: November 4, 1999)

For: METHOD OF FABRICATING A)

SEMICONDUCTOR DEVICE)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on August 15, 2001.

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents and Trademarks
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference listed on the attached Form PTO-1449 be made of record in the above-identified application. A copy of the reference is submitted herewith in accordance with 37 C.F.R. 1.98(a).

Applicant wishes to submit the English language abstract of JP 09-293600, which was previously submitted as a Japanese language document only, in an Information Disclosure Statement dated July 5, 2001.

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380 (740756-2062).

Respectfully submitted,

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